

In re Application of:
Hansen, et al.

Confirmation No.: 1040

For: Apparatus and Method for
Single Substrate
Processing Using
Megasonic-Assisted Drying

Group Art Unit: 1763

Examiner: Rakesh K. Dhimgra

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Rakesh K. Dhingra on the date shown below.

August 14, 2006

Date _____

Steven H VerSteeg

Dear Sir:

**RESPONSE TO FINAL OFFICE ACTION DATED JUNE 22, 2006 AND INTERVIEW
SUMMARY DATED AUGUST 1, 2006**

In response to the Final Office Action dated June 22, 2006, having a shortened statutory period for response set to expire on September 22, 2006, please enter this response and reconsider the claims pending in the application for the reasons discussed below. Although Applicants believe that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/010533.C1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 5 of this paper.